



Application No.: 10/060,826
Docket No.: IB-1581/LBNL 207/10413310

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Daniel S. Pickard et al.

Application No.: 10/060,826

Confirmation No.: 9952

Filed: February 1, 2002

Art Unit: 2821

For: MATCHING NETWORK FOR RF PLASMA
SOURCE

Examiner: W. Lee

AMENDMENT IN RESPONSE TO NON-FINAL OFFICE ACTION

MS Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the Office action dated August 24, 2004 please amend the above-identified U.S. patent application as follows:

Amendments to the Claims and new claims begin on page 2 of this paper.

Remarks begin on page 6 of this paper.

01/27/2005 AWONDAF1 00000100 10060826

01 FC:2201	100.00 DP
02 FC:2202	100.00 DP